



#18
7/29/03

M

RECEIVED
JUL 22 2003
GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Small et al.

Assignee: EKC Technology, Inc.

Title: Catalytic Composition for Chemical-Mechanical Polishing, Method of Using Same, and Substrate Treated with Same

Application No.: 10/074,757 Filing Date: February 11, 2002

Examiner: Marcheschi, Michael A. Group Art Unit: 1755

Docket No.: CHEM.004US0 Conf. No.: 9276

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 7/14/03

Eileen Bone
Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicants respectfully petition for a three-month extension of time within which to respond to the January 15, 2003 outstanding Office Action, such extension allowing the undersigned until July 15, 2003 to respond.

209

07/17/2003 CCHAU1

0000092 10074757

01 FC:1253

930.00 OP

CHEM.004US0

-1-

Serial No.: 10/074,757

A check is enclosed that includes the amount of \$930.00, as set forth in the enclosed transmittal letter.

Respectfully submitted,

K. Alison de Runtz

K. Alison de Runtz
Attorney of Record
Reg. No. 37,119

July 14, 2003

Date

PARSONS HSUE & DE RUNTZ LLP
655 Montgomery Street, Suite 1800
San Francisco, CA 94111
(415) 318-1160
(415) 693-0194 fax

OK TO